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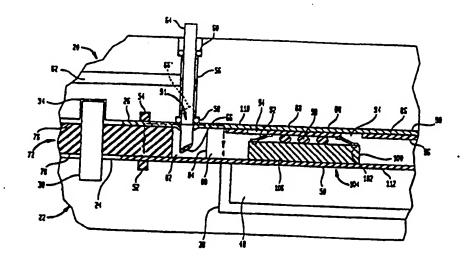
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(54) Tile: ENCAPSULATION OF MICROFLECTRONIC ASSEMBLIES



## (57) Abstract

Microelectronic assemblies are encapsulated using disposable frames (72). The microelectronic assemblies (104) are disposed within an aperture (80) defined by a frame. The aperture is covered by top and bottom scaling layers (110, 112) so that the frame and scaling layers define an exclosed space encompassing the assemblies. The encapsulant is injected into this closed space. The frame is then expansion from the encapsulation fixture and held in a curing oven. After cure, the frame is cut apart and the individual assemblics are severed from another. Because the frame need not be held in the encapsulation fixture during curing, the process achieves a high throughput.